

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/614,019	TANIGUCHI ET AL.	
Examiner	Art Unit	
Jacqueline Cheng	3768	

	SEAR	EARCHED	
Class	Subclass	Date	Examiner
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Class	Subclass	Date	Examiner
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
see attached search history	7/3/2007	JC		